

11/05/98
JC525 U.S. PTO
09/186388
11/05/98

COMMISSIONER OF PATENTS AND TRADEMARKS
Washington, D.C. 20231

Docket No. CS97-110/112

Transmitted herewith for filing is the Patent Application of:

Inventor: BUAN HENG LEE, TECK HONG LOW, HAI RONG WANG, TANG YING

AND ZADIG CHERNG-CHING LAM

For: N TYPE IMPURITY DOPING USING IMPLANTATION OF P2+ IONS OR AS2+ IONS

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Enclosed are:

- ☒ 2 sheets of formal drawing(s).
- ☒ An assignment of the invention to Chartered Semiconductor Manufacturing, Ltd.
- ☐ An associate power of attorney

The filing fee has been calculated as shown below:

	(Col. 1)	(Col. 2)	OTHER THAN A SMALL ENTITY	
FOR:	NO. FILED	NO. EXTRA	RATE	FEE
BASIC FEE				\$ 790.
TOTAL CLAIMS	28 -20=	8	x 22 =	\$ 176.
INDEP CLAIMS	4 -3=	1	x 82 =	\$ 82.
MULTIPLE DEPENDENT CLAIM PRESENTED			+ 260 =	
			SUB TOTAL	\$ 1,048.
			ASSIGNMENT	\$40.
			TOTAL	\$ 1,088.

- ☒ Please charge my Deposit Account No. 19-0033 in the amount of \$ 1,088. A duplicate copy of this sheet is enclosed.
- ☒ The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 19-0033. A duplicate copy of this sheet is enclosed.
- ☒ Any additional filing fees required under 37 CFR \$1.16.
- ☒ Any patent application processing fees under 37 CFR \$1.17.

Respectfully submitted,

STEPHEN B. ACKERMAN, REG. NO. 37,761